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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

1

Complete if Known

Application Number	10/582,033
Filing Date	08/21/2007
First Named Inventor	Kyle JIANG
Art Unit	10582033 - GAU: 1795
Examiner Name	
Attorney Docket Number	7492-105

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
/TC/	EP	0385122	09/05/1990	International Business Machines		

**Examiner
Signature**

/Thorl Chea/

Date
Considered

08/07/2009

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Substitute for form 1449B/PTO				<i>Complete if Known</i>	
				<i>Application Number</i>	107582,033
				<i>Filing Date</i>	08/21/2007
				<i>First Named Inventor</i>	Kyle JIANG
				<i>Art Unit</i>	10582033 - GAU: 1795
				<i>Examiner Name</i>	
(Use as many sheets as necessary)					
Sheet	1	of	1	<i>Attorney Docket Number</i>	7492-105

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/TC/		ZHONG-GENG LING; KUN LIAN; LINKE JIAN, "Improved patterning quality of SU-8 microstructures by optimizing the exposure parameters," Proc. of Spie; Advances in Resist Technology and Processing XVII, p. 1019-1027,	
/TC/		CONRADIE E H ET AL., "SU-8 thick photoresist processing as a functional material for MEMS applications," journal, Journal of Micromechanics & Microengineering (New York, NY), Vol. 12 (No. 4), p. 368-374,	

Examiner Signature	/Thorl Chea/	Date Considered	08/07/2009
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